

SEP 30 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Lian, et al.

Docket No.: 2004P51100US/
INTECH 3.0-050DIV

Serial No.: 10/803,363

Art Unit: 2822

Filed: March 17, 2004

Examiner: Thanh Y. Tran

Title: Adhesion Layer for Pt on SiO₂

Mail Stop: Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office Action mailed June 30, 2005. Please amend the above-referenced application as follows.

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Amendment